## **McDermott** Will&Emery

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APR 1 1 2006

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**FACSIMILE** 

Date:

April 11, 2006

Time Sent:

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To:	Company:	Facsimile No:	Telephone No:	1	
Examiner Dilinh Nguyen	U.S. Patent and Trademark Office	571-273-8300			
From:	Ramyar M. Farid	Direct Phone:	202.756.8146		
E-Mail:	rfarid@mwe.com	Direct Fax:	202.756.8087		
Sent By:	Matilda Mason	Direct Phone:	202-756-8661		
Client/Matter/Tkpr:	60188-717	Original to Follow by Mail:		No	
-		Number of Pages, Including Cover:		9	

Re:

Application No.:

10/720,197

Attorney Docket No.:

60188-717

Message:

This Response is being filed in response to the Office Action dated January 11, 2006.

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U.S. practice conducted through McDermott Will & Emery LLP. Washington, D.C. 20005-3096

Telephone: 202.756.8000

# McDermott HECEIVED CENTRAL FAX CENTER

APR 1 1 2006

Docket No.: 060188-0717

**PATENT** 

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Hideaki OKAMURA, et al.

Confirmation Number: 4226

Application No.: 10/720,197

Group Art Unit: 2814

Filed: November 25, 2003

Examiner: Dilinh Nguyen

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

Politica de la companya del companya del companya de la companya d	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	7	20	0	\$50.00 =	\$0.00
Independent Claims	1	3	0	\$200.00 =	\$0.00
		Multiple dependen	Multiple dependent claims newly presented		
		Fee for extension of time			\$0.00
					\$0.00
Total of Above Calculations				\$0.00	

Please charge my Deposit Account No. 500417 in the amount of \$0.00.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LL

Ramyar M. Farid

Registration No. 46,692

Please recognize our Customer No. 20277 as our correspondence address.

600 13<sup>th</sup> Street, N.W. Washington, DC 20005-3096 Phone: 202.756.8000 RMF:MaM

Facsimile: 202.756.8087 Date: April 11, 2006

WDC99 1220586-1 060188.0717

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In re Application of

Customer Number: 20277

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Examiner: Dilinh Nguyen

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

#### **AMENDMENT**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 11, 2006, having a three-month shortened statutory period for response set to expire on April 11, 2006, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.